

Title (en)

Sensor controlled hot plate with sensor arranged below the plate

Title (de)

Sensorgesteuertes Kochfeld mit unterhalb der Kochfeldplatte angeordneter Sensoreinheit

Title (fr)

Régulateur de plaque chauffante à l'aide d'un détecteur situé en dessous de la plaque

Publication

EP 1006756 B1 20020605 (DE)

Application

EP 99123600 A 19991126

Priority

DE 19856140 A 19981204

Abstract (en)

[origin: EP1006756A1] The value of the transmission of a cooking plate (3) in a spectral measurement aperture (18) towards the infrared (IR) radiation sensor (19) is smaller than 10% approaching 0%. A reflection-layer (17) is deposited on wall of a measurement hole (15) to increase of sensitivity the measurement. Under a cooking plate (3), a measurement aperture (18) passes the heat radiation towards the IR sensor (19).

IPC 1-7

H05B 6/06; H05B 6/08; H05B 6/12; H05B 1/02; H05B 3/00; H05B 3/68; G02B 6/00

IPC 8 full level

G02B 6/00 (2006.01); H05B 1/02 (2006.01); H05B 3/00 (2006.01); H05B 3/68 (2006.01); H05B 3/74 (2006.01); H05B 6/06 (2006.01); H05B 6/08 (2006.01); H05B 6/12 (2006.01)

CPC (source: EP US)

H05B 3/746 (2013.01 - EP US); F24C 7/083 (2013.01 - EP); F24C 15/105 (2013.01 - EP); H05B 2213/07 (2013.01 - EP US)

Cited by

DE102013102112A1; DE102013102115A1; EP2405712A4; EP2117281A3; EP2775786A1; EP2775791A1; US8581159B2; US9414443B2; WO2008148529A1

Designated contracting state (EPC)

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